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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(s) : Sven Hansen

SERIAL NO. : 10/767,124 ART UNIT: 2851

FILING DATE: 1/29/2004 EXAMINER: Nelson,
Vivian Hsu

TITLE: METHOD AND DEVICE FOR ADJUSTING AN ALIGNMENT
MICROSCOPE BY MEANS OF A REFLECTIVE ALIGNMENT
MASK

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DOCKET NO.: 873-011675-US (PAR)

Mail Stop Amendment
Commissioner of Patents
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AMENDMENT

I. INTRODUCTION

This is in response to the Office Action mailed July 18, 2005 (Paper No./Mail Date 20050707) in regard to the above-identified patent application. Reconsideration of the rejection of the claims is respectfully solicited in light of the following amendment and remarks.

Please amend the Application as follows: